	12-12-2000	
	Form PTO 1595	EET U.S. DEPARTMENT OF COMMERCE
	To the Hanarchia Commissio	Patent and Trademark Office  d the attached original documents or copy thereo:
1,	Name of conveying parties: Execution Date: Hakeem Oluseyi	ume and address of receiving parties:  Name: Applied Materials, Inc.  Internal Address: Legal Affairs Department - M/S 2061
	Moshe Sarfaty	Street Address: P. O. Box 450A City: Santa Clara State: CA Zip: 95052
Ad	ditional names of conveying Parties attached? □Yes ⊠ No	Additional Names & Addresses attached? □Yes ⊠ No
3.	Nature of conveyance;	11-21-00 09/721403
4.	Application number or patent number:	0
	PROCESS CONDITIONS OF A SEMICONDUCTOR PROCE  A. Patent Application No <u>unassigned</u> ; filed here with	B. Patent No.(s)
	Additional Numbers attac	oched? □Yes ⋈ No
5.	Name and address of party to whom correspondence concerning this document should be mailed:  Name: ROBERT W. MULCAHY	6. Total number of applications and patent involved. 1
	Internal Address: Applied Materials, Inc.  Legal Affairs Department - M/S 2061  Street Address: P. O. Box 450A  City: Santa Clara State: CA Zip: 95052	7. Total Fee (37 CFR 3.41) \$40.00  □ Enclosed  ■ Authorized to be charged to deposit account
		8. Deposit Account Number: 50-1074
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9.	Statement and signature.	
	the best of my knowledge and belief, the foregoing information is ument.	true and any attached copy is a true copy of the original

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Signature

Robert W. Mulcahy, Reg. No. 25,436

Name of Person Signing

10.

PATENT REEL: 011313 FRAME: 0660

Date

## ASSIGNMENT FOR APPLICATION FOR PATENT

WHEREAS:

Names and Addresses of the Inventors:

Hakeem Oluseyi	Moshe Sarfaty
82-F Escondido Village	10203 Parkwood Drive #8
Stanford, California 94305	Cupertino, California 95014

(hereinafter referred to as Assignors), has invented a certain invention entitled:

## A METHOD AND APPARATUS EMPLOYING OPTICAL EMISSION SPECTROSCOPY TO DETECT A FAULT IN PROCESS CONDITIONS OF A SEMICONDUCTOR PROCESSING SYSTEM

for which application for Letters Patent in the United States is filed herewith,

under Serial No. unassigned, executed on even date herewith;

WHEREAS, Applied Materials, Inc., a corporation of the State of Delaware, having a place of business at 3050 Bowers Avenue, Santa Clara, California 95054 (hereinafter referred to as Assignee), is desirous of acquiring the entire right, title and interest in and to said application (hereinafter referred to as the Application), and the invention disclosed therein (hereinafter referred to as the Invention), and in and to all embodiments of the Invention, heretofore conceived, made or discovered by said Assignors, and in and to any and all patents, inventor's certificates and other forms of protection (hereinafter referred to as the Patents) thereon granted in any and all countries and groups of countries.

NOW, THEREFORE, in consideration of good and valuable consideration acknowledged by said Assignors to have been received in full from said Assignee:

- 1. Said Assignors hereby sells, assigns, transfers and conveys to Assignee the full and exclusive right, title and interest (a) in and to said Application and said Invention; (b) in and to all rights to apply for patents on said Invention in any and all countries pursuant to the International Convention for the Protection of Industrial Property or otherwise; (c) in and to any and all Applications filed and any and all Patents granted on said Invention in any and all countries and groups of countries, including each and every Application filed and each and every Patent granted on any application which is a division, substitution, or continuation of said Application; and (d) in and to each and every reissue or extension of any of said Patents.
- Said Assignors hereby covenants and agrees to cooperate with said Assignee to enable said Assignee to enjoy to the fullest extent the right, title and interest to said Invention herein conveyed in any and all countries and groups of countries. Such cooperation by said Assignors shall include prompt production of pertinent facts and documents, giving testimony, execution of petitions, oaths, specifications, declarations or other papers, and other assistance all to the extent deemed necessary or desirable by said Assignee (a) for perfecting in said Assignee the right, title and interest herein conveyed; (b) for prosecuting any of said applications; (c) for filing and prosecuting substitute, divisional, continuing or additional applications covering said Invention; (d) for filing and prosecuting applications for reissuance of any of said Patents; (e) for interference or other priority proceedings involving said Invention; and (f) for legal proceedings involving said Invention and any application therefor and any Patents granted thereon, including without limitation opposition proceedings, cancellation proceedings, priority contests, public use proceedings, infringement actions and court actions; provided, however, that the expense incurred by said Assignors in providing such cooperation shall be paid for by said Assignee.
  - 3. The term and covenants of this agreement shall inure to the benefit of said Assignee, its

PATENT REEL: 011313 FRAME: 0661 successors, assigns and other legal representatives, and shall be binding upon said Assignors, their respective heirs, legal representatives and assigns.

- 4. Said Assignors hereby warrants and represents that he has not entered and will not enter into any assignment, contract, or understanding in conflict herewith.
- 5. Said Assignors hereby authorizes and requests the attorneys of record to insert, where indicated above, the application number and filing date of said application when known.

IN WITNESS WHEREOF, the said Assignors has executed and delivered this instrument to said

Assignee on the dates indicated below.

*i*, . . . , 2000

11 2 , 2000

**RECORDED: 11/21/2000** 

Hakeem Olusey

Moshe Sarfaty